

Notice of References Cited	Application/Control No. 10/810,690		Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Jean A. Gelin		Art Unit 2617	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0009578	01-2005	Liu, Yonghe	455/574
*	B	US-2003/0050104	03-2003	Matsumura et al.	455/574
*	C	US-2003/0181163	09-2003	Ofuji et al.	455/25
*	D	US-5,560,021	09-1996	Vook et al.	713/323
*	E	US-6,052,565	04-2000	Ishikura et al.	455/67.11
*	F	US-6,078,566	06-2000	Kikinis, Dan	370/286
*	G	US-6,192,230	02-2001	van Bokhorst et al.	455/343.3
*	H	US-2003/0203741	10-2003	Matsuo et al.	455/519
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.